
**Lasers and laser-related equipment —
Test methods for laser beam
widths, divergence angles and beam
propagation ratios —**

**Part 1:
Stigmatic and simple astigmatic
beams**

*Lasers et équipements associés aux lasers — Méthodes d'essai des
largeurs du faisceau, angles de divergence et facteurs de limite de
diffraction —*

Partie 1: Faisceaux stigmatiques et astigmatiques simples



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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see www.iso.org/directives).

Attention is drawn to the possibility that some of the elements of this document may be the subject of patent rights. ISO shall not be held responsible for identifying any or all such patent rights. Details of any patent rights identified during the development of the document will be in the Introduction and/or on the ISO list of patent declarations received (see www.iso.org/patents).

Any trade name used in this document is information given for the convenience of users and does not constitute an endorsement.

For an explanation of the voluntary nature of standards, the meaning of ISO specific terms and expressions related to conformity assessment, as well as information about ISO's adherence to the World Trade Organization (WTO) principles in the Technical Barriers to Trade (TBT), see www.iso.org/iso/foreword.html.

This document was prepared by Technical Committee ISO/TC 172, *Optics and photonics*, Subcommittee SC 9, *Laser and electro-optical systems*, in collaboration with the European Committee for Standardization (CEN) Technical Committee CEN/TC 123, *Lasers and photonics*, in accordance with the Agreement on technical cooperation between ISO and CEN (Vienna Agreement).

This second edition cancels and replaces the first edition (ISO 11146-1:2005), which has been technically revised. The main changes compared to the previous edition are as follows:

- The terms and definitions were harmonized with the new edition of ISO 11145.
- The "principal axes" were defined more thoroughly and named as x' and y' . Quantities related to the principal axes coordinate system refer to this definition and use x' and y' in their indices.
- The requirements for the integration range for the determination of the second order moments have been relaxed.

A list of all parts in the ISO 11146 series can be found on the ISO website.

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at www.iso.org/members.html.

Introduction

The propagation properties of every laser beam can be characterized within the method of second order moments by ten independent parameters (see ISO/TR 11146-3). However, due to their higher symmetry most laser beams of practical interest need fewer parameters for a complete description. Most lasers of practical use emit beams which are stigmatic or simple astigmatic because of their resonator design.

This document describes the measurement methods for stigmatic and simple astigmatic beams while ISO 11146-2 deals with the measurement procedures for general astigmatic beams. For beams of unknown type the methods of ISO 11146-2 are applicable. Beam characterization based on the method of second order moments as described in both parts is only valid within the paraxial approximation.

The theoretical description of beam characterization and propagation as well as the classification of laser beams is given in ISO/TR 11146-3, which is a Technical Report and describes the procedures for background subtraction and offset correction.

In this document, the second order moments of the power (energy) density distribution are used for the determination of beam widths. However, there may be problems experienced in the direct measurement of these quantities in the beams from some laser sources. In this case, other indirect methods of the measurement of the second order moments may be used as long as comparable results are achievable.

In ISO/TR 11146-3, three alternative methods for beam width measurement and their correlation with the method used in this document are described. These methods are:

- variable aperture method;
- moving knife-edge method;
- moving slit method.

Lasers and laser-related equipment — Test methods for laser beam widths, divergence angles and beam propagation ratios —

Part 1: Stigmatic and simple astigmatic beams

1 Scope

This document specifies methods for measuring beam widths (diameter), divergence angles and beam propagation ratios of laser beams. This document is only applicable for stigmatic and simple astigmatic beams. If the type of the beam is unknown, and for general astigmatic beams, ISO 11146-2 is applicable.

2 Normative references

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies

ISO 11145, *Optics and photonics — Lasers and laser-related equipment — Vocabulary and symbols*

ISO 11146-2, *Lasers and laser-related equipment — Test methods for laser beam widths, divergence angles and beam propagation ratios — Part 2: General astigmatic beams*

ISO 13694, *Optics and photonics — Lasers and laser-related equipment — Test methods for laser beam power (energy) density distribution*

EN 61040:1992, *Power and energy measuring detectors, instruments and equipment for laser radiation*

3 Terms and definitions

For the purposes of this document, the terms and definitions given in ISO 11145, ISO 13694, EN 61040 and the following apply.

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

- ISO Online browsing platform: available at <https://www.iso.org/obp>
- IEC Electropedia: available at <https://www.electropedia.org/>

NOTE The x-, y- and z-axes in these definitions refer to the laboratory system as described in [Clause 4](#). Here and throughout this document the term “power density distribution $E(x,y,z)$ ” refers to continuous wave sources. It might be replaced by “energy density distribution, $H(x,y,z)$ ” in case of pulsed sources.